

DOCKET NO: 284119US2X PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
KATSUTOSHI TAKAGI, ET AL. : EXAMINER: YANG, JIE
SERIAL NO: 10/564,502 :
FILED: JANUARY 13, 2006 : GROUP ART UNIT: 1793
FOR: AG BASE SPUTTERING TARGET :
AND PROCESS FOR PRODUCING THE :
SAME

STATEMENT OF SUBSTANCE OF INTERVIEW

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Pursuant to 37 C.F.R. §1.133 and MPEP 713.04, Applicants respectfully submit the following Interview Summary.

Applicants thank the Examiner for the courtesy of a telephone interview extended to Applicants' representative on March 2, 2010. During the interview, Applicants' representative Robert T. Pous authorized Examiner Jie Yang to amend Claim 3 by Examiner's Amendment. Examiner Yang agreed as noted in Notice of Allowance of March 25, 2010.

Respectfully submitted,

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